## HE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re application of:            |  |
|----------------------------------|--|
| Masaya Kadono, et al.            | I hereby certify that this correspondence is being deposited with the United States Postal Service |
| Serial No.: 09/535,233           | as first class mail in an envelope addressed to:   |
|                                  | Commissioner for Patents   |
| Filed: March 24, 2000            | P.O. Box 1450  |
|                                  | Alexandria, VA 22313-1450  |
| Examiner: William D. Coleman )   | DATE: March 31, 2005   |
| Art Unit: 2823 )                 | NAME:Christine A. Barglik  |
| Art Ollit. 2823 )                | SIGNATURE: Chustine a Bargik   |
| For: A METHOD OF MANUFACTURING ) |  |
| <b>/</b>                         |  |
| A SEMICONDUCTOR DEVICE )         |  |

**Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

## **RESPONSE TO OFFICE ACTION**

## Dear Examiner:

This is a Response to the Office Action mailed January 4, 2005.